

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Yusuke MURAOKA et al.

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For: SUBSTRATE PROCESSING METHOD, SUBSTRATE PROCESSING APPARATUS

AND SUBSTRATE PROCESSING SYSTEM

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## **SUBMISSION**

Sir:

Submitted herewith is a copy of art together with a form listing the same for the convenience of the Examiner.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents P.O. Box 1450, Alexandria, VA 22313-1450, on January 23, 2004

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Signature

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JAF:msd Enclosure